

42390.P11026

PATENT

19/13



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kloster, et al.

Serial No.: 09/820,079

Filed: March 28, 2001

For: STRUCTURE IN A
MICROELECTRONIC DEVICE
INCLUDING A BI-LAYER FOR A
DIFFUSION BARRIER AND AN
ETCH STOP LAYER

Examiner: Thomas J. Magee

Group Art Unit: 2811

Attorney Docket No.: 42390.P11026

8/5/03
John H

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 on:

22 July 2003

Date of Deposit

DEBORAH L. HIGHAM

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Signature

7/22/03

Date

PRELIMINARY AMENDMENT

Hon. Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

Prior to examination of the claims on the merits, Applicants respectfully request that the Examiner enter the following amendments and consider the following remarks:

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